04-15-2005 RE 102982156	Attorney Docket U 015	
To the Honorable Commissioner of Patents and Tradettians. The	and itached original documents or copy thereo	
1. Name of conveying party(ies):	2. Name and address of receiving party (ies):	
 MIN-LUNG HUANG 3. Additional name(s) of conveying party(ies) attached? Yes X No 	Name: ADVANCED SEMICONDUCTOR ENGINEERING INC. Address: 26 CHIN 3 RD ROAD, NANTZE EXPORT PROCESSING ZONE KAOHSIUNG, TAIWAN, R.O.C.	
3. Nature of conveyance:		
Assignment Images Security Agreement Images Other Images Execution Date(s): 1. 2. 3.	Additional name(s) & addresses(es) attached?	
4. Application number(s) or patent number(s)	326 1/(G	
Patent Application No.(s): Additional numbers attach	ed? Yes No.(s):	
5. Name and address of party to whom correspondence concerning document should be mailed:	6. Total number of applications and patents involved:	
Name: Clifford J. Mass	7. Total fee (37 CFR 3.41) \$@ \$40.00 each	
Address: Ladas & Parry LLP 26 West 61 st Street New York, N.Y. 10023	Check EnclosedAuthorized to be charged in whole or in part to:	
/	8. Deposit account number: <u>12-0425</u>	
DO NOT AISE TH	US SPACE	
9. Signature:	<u>b 3046</u> Date	
Clifford J. Mass Name of Person Signing Total number of pages including coversheet attachments, and documents:	3	

PATENT REEL: 016453 FRAME: 0353

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ASSIGNMENT

In consideration of the sum of Ten Dollars (\$10.00) and other good and valuable consideration paid to each of the undersigned, to wit:

	(1) <u>Min-Lung Huang</u> (5)			
Insert Name(s) of Inventor(s)	(2)(6)			
07 11101 (3)	(3)(7)			
	(4) [] x box if continued on back			
	the receipt and sufficiency of which are hereby acknowledged by the undersigned who at the request of, hereby sell(s), assign(s) and transfer(s) unto:			
Insert Name	ADVANCED SEMICONDUCTOR ENGINEERING, INC.			
of Assignee and Address	26 Chin 3 rd Road, Nantze Export Processing Zone Kaoshiung, Kaoshiung Taiwan, R.O.C.			
	(hereinafter designated "ASSIGNEE") the entire right, title and interest for the United States of America as defined in 35 U.S.C. 100, in and to the invention known as			
Title of Invention	METHOD FOR FORMING A REDISTRIBUTION LAYER IN A WAFER STRUCTURE			
	for which an application for Letters Patent of the United States of America has been			
NOTE -> -> ->	executed even date herewith by the undersigned, and in and to any and all divisions,			
(use only continuations, substitutes, and reissues thereof; and all resulting pater when appln. undersigned hereby authorize(s) and request(s) the United States Commission				
signed on	undersigned hereby authorize(s) and request(s) the United States Commissioner or Patents and Trademarks to issue said Letters Patent to the said ASSIGNEE, for its			
same date)	interest as ASSIGNEE, its successors, assigns and legal representatives; the			
	undersigned agree(s) that the attorneys of record in said application shall hereafter act			
	on behalf of said ASSIGNEE;			
	AND the undersigned hereby agree(s) to testify and execute any papers for			
	ASSIGNEE, its successors, assigns and legal representatives, deemed essential by ASSIGNEE to ASSIGNEE'S full protection and title in and to the invention hereby			
	transferred.			
Diama sign				

Please sign concurrently

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	INVENTOR(S)	DATE SIGNED	
1)	Humy Min-Lung YVer Name: Min-Lung Huang	Vilou	
	Name: Min-Lung Huang		
2)			
	Name:		
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	Name:		
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	Name:		
7)			
	Name:		

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